IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No	10/041,896
Filing Date	January 7, 2002
Inventorship	
Assignee	Micron Technology, Inc.
Group Art Unit	
Examiner	
Attorney's Docket No	MI22-1859
Customer No	021567
Title: DRAM Circuitry Having Storage	
Dielectric Regions Comprising Aluminum Nitride	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are attached hereto. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a request for continued examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted, TECHNOLOGY CENTER 2800 Mark S. Matkin Reg. No. 32,268 1

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